IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	CHAD RUE, ET AL.)
Serial No.:	10/711,691) Group Art Unit: 2881
Filed:	September 30, 2004) Examiner: Yantorno, J.
For:	APPARATUS AND METHOD FOR MANIPULATING SAMPLE TEMPERATURE FOR FOCUSED ION BEAM PROCESSING)) Confirmation No.: 5690)

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In response to the Office Action mailed March 17, 2006, please amend the Application as follows: